

Receipt
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S/N: 09/718,319



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Yuen, et al.	Group Art Unit: 1765
Serial No: 09/718,319	Attention: Office of Initial Patent Examination
Confirmation No: 3056	Customer Service Center
Filed: 11/21/2000	Atty Docket No. 004704 USA/ETCH/SILICON/JB1
For: Etching a Substrate in a Process Zone	May 17, 2001 San Francisco, California

CORRECTION TO FILING RECEIPT

Office of Initial Patent Examination
Customer Service Center
Commissioner for Patents
Washington, D.C. 20231

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Sir/Madam:

Applicant respectfully requests the Patent Office to correct the Filing Receipt and forward a corrected copy to Applicant.

Please note the change highlighted on the enclosed copy of the Filing Receipt. Specifically, the correction is as follows:

1. Filing Date should read:

11/21/2000

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to:

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By

Rowena Montoya
Rowena Montoya

Dated May 17, 2001


S/N: 09/718,319

If the Examiner should have any questions regarding the above correction, the Examiner is requested to telephone the Applicant's representative at the number listed below.

Respectfully submitted,

JANAH & ASSOCIATES
A PROFESSIONAL CORPORATION

Date: 5/17/01

By: 
Ashok K. Janah
Reg. No. 37,487

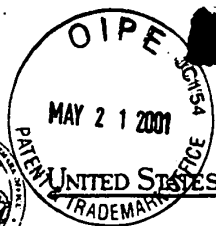
Please direct all telephone calls to:

Ashok Janah
(415)538-1555

Please continue to send all correspondence to:

Patent Counsel
APPLIED MATERIALS, INC.
P.O. Box 450A
Santa Clara, CA 95052

Encl.



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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/718,319	11/22/2000	1765	1722	4704/USA/ETCH/SILICON	6	54	8

11/21/2000

CONFIRMATION NO. 3056

FILING RECEIPT



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APPLIED MATERIALS, INC.
Patent Department
P.O. Box 450A
Santa Clara, CA 95052

Date Mailed: 03/28/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the PTO processes the reply to the Notice, the PTO will generate another Filing Receipt incorporating the request d corrections (if appropriate).

Applicant(s)

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Continuing Data as Claimed by Applicant

Foreign Applications

If Required, Foreign Filing License Granted 03/28/2001

Projected Publication Date:

Non-Publication Request: No

Early Publication Request: No

Title

Etching a substrate in a process zone

Preliminary Class

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